



PATENT

Atty. Dkt. No. AMAT/5262/CMP/CMP/RKK

AF  
1753

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

~~MRK 10~~ Application of:  
Tsai, et al.

Confirmation No.: 411

Confirmation No.: 4110

Filed: September 21, 2001

**For:** Method and Apparatus For  
Forming Metal Layers

Group Art Unit: 1753

Examiner: Wong, Edna

MAIL STOP AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**CERTIFICATE OF MAILING**  
**37 CFR 1.8**

Dear Sir:

**RESPONSE TO FINAL OFFICE ACTION DATED FEBRUARY 6, 2004**

In response to the Final Office Action dated February 6, 2004, having a shortened statutory period for response set to expire on May 6, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/5262/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

**Amendments to the Specification** begin on page 2 of this paper. **Amendments to the Claims** are reflected in the listing of claims which begins on page 4 of this paper. **Remarks** begin on page 5 of this paper.